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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTO	R	ATTORNEY DOCKET NO.
09/450,351	11/29/9	9 YAMAMOTO	Ţ	SHM-00901
	intoderen 7.4.4			EXAMINER
PATENT GROUP HUTCHING, WHEELER & DITTMAR			TSA	[, H
			ART UNI	T PAPER NUMBER
101 FEDERAL STREET BOSTON MA 02110			281	2
			DATE MAILE	:D: 11/01/00

Please find below and/or attached an Office communication concerning this application or proceeding.

Commissioner of Patents and Trademarks

Office Action Summary

Application No. 09/450,351 Applicant(s)

Yamamot

Examiner

H, Jey Tsai

Group Art Unit 2812

Responsive to communication(s) filed on	
This action is FINAL .	
Since this application is in condition for allowance except in accordance with the practice under <i>Ex parte Quayle</i> , 1	
	et to expire3 month(s), or thirty days, whichever ure to respond within the period for response will cause the ensions of time may be obtained under the provisions of
Disposition of Claims	
	is/are pending in the application.
Of the above, claim(s)	is/are withdrawn from consideration.
Claim(s)	
Claim(s)	
	are subject to restriction or election requirement.
Application Papers	
☐ See the attached Notice of Draftsperson's Patent Drav	wing Review, PTO-948.
☐ The drawing(s) filed on is/are ob	ojected to by the Examiner.
☐ The proposed drawing correction, filed on	is 🗖 approved 🗖 disapproved.
$\hfill\Box$ The specification is objected to by the Examiner.	
\square The oath or declaration is objected to by the Examiner	r.
Priority under 35 U.S.C. § 119	
Acknowledgement is made of a claim for foreign prior	rity under 35 U.S.C. § 119(a)-(d).
	es of the priority documents have been
🛛 received.	
☐ received in Application No. (Series Code/Serial	Number)
received in this national stage application from	the International Bureau (PCT Rule 17.2(a)).
*Certified copies not received:	
Acknowledgement is made of a claim for domestic principle.	iority under 35 U.S.C. § 119(e).
Attachment(s)	
Notice of References Cited, PTO-892	
☑ Information Disclosure Statement(s), PTO-1449, Pape	er No(s)
Interview Summary, PTO-413	2040
Notice of Draftsperson's Patent Drawing Review, PTO	J-948
□ Notice of Informal Patent Application, PTO-152	
SEE OFFICE ACTION C	ON THE FOLLOWING PAGES

Serial Number: 09/450,351 Page 2

Art Unit: 2812

Claim Rejections - 35 U.S.C. § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-20 are rejected under 35 U.S.C. 103(a) as being unpatentable over Nishikawa 6,087,261 in view of Tamaru et al. 6,103,566 and Lee et al. 6,010,940.

The reference(s) teach the features:

Nishikawa substantially discloses a method of forming a capacitor on the semiconductor device, which includes:

forming a tantalum oxide dielectric layer 5, fig. 4B,

treating substrate in the chamber with at least one of a gas containing non-reactive NH_3 and helium gases flow, col. 9, lines 1+,

Serial Number: 09/450,351

Art Unit: 2812

heating the substrate in the $\mathrm{NH_{3}}$ ambient at about 0.15 torr, fig. 6, col. 9, lines 30+,

introducing the source gas containing a high melting point $metal\ TiCl_4$ to form $TiN\ layer\ 6.$

The difference between the reference(s) and the claims are as follows:

Nishikawa et al. teaches using helium as inert gas.

However, Tamaru et al. teaches using nitrogen gas during the heat treatment process, before introducing NH₃, then forming metal nitride with high melting metal containing gas in col. 18, lines 27+ and col. 16, lines 20. And, Lee teaches annealing the substrate with NH₃ after forming TiN.

It would have been obvious to one having ordinary skill in the art at the time the invention was made to have modified Nishikawa et al.'s process with nitrogen gas to stabilize the tantalum oxide with heat treating step as suggested by Tamaru et al. because nitrogen does not reoxidize the tantalum oxide.

Any inquiry of a general nature or clerical matters or relating to the status of this application or proceeding should be directed to the Group customer service whose telephone number

Serial Number: 09/450,351

Art Unit: 2812

is (703) 306-3329 and Fax number (703) 306-5515. Group receptionist telephone number 703-308-0956.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to H. Jey Tsai whose telephone number is (703) 308-1374. The examiner can normally be reached on from 7:00 Am to 4:00 Pm., Monday thru Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John Niebling can be reached on (703) 308-3325. The fax phone number for this Group is (703) 305-3431.

hjt 10/23/0

> H. Jey Tsai Primary Examiner

Patent Examining Group 2800